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SERIAL NUMBER 10/568,186	FILING OR 371(c) DATE 03/03/2006 RULE	CLASS 117	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 126961
APPLICANTS Izumi Fusegawa, Fukushima, JAPAN; Nobuaki Mitamura, Fukushima, JAPAN; Takahiro Yanagimachi, Fukushima, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/11685 08/13/2004				
** FOREIGN APPLICATIONS ***** JAPAN 2003-296837 08/20/2003				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/20/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Allowance</i> Examiner's Signature <i>PSH.</i> Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 17
				INDEPENDENT CLAIMS 2
ADDRESS 25944				
TITLE Method for producing a single crystal and silicon single crystal wafer				
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	